

# Search Notes



Application No.

09/938,698

Examiner

Ken A Berck

Applicant(s)

SASHIRO UEMURA

Art Unit

2879

## SEARCHED

| Class | Subclass | Date    | Examiner |
|-------|----------|---------|----------|
| 513   | 495      | 4/11/03 | 082-     |
|       | 309      |         |          |
|       | 336      |         |          |
|       | 371      |         |          |
|       | 497      |         |          |
|       | 311      |         |          |
|       | 477R     |         |          |
| 313   | 36       | 1/10/04 | 607      |
|       | 44       |         |          |
|       | 474      |         |          |
|       | 478      |         |          |
|       | 35       |         |          |
|       | 45       |         |          |
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## INTERFERENCE SEARCHED

| Class | Subclass | Date | Examiner |
|-------|----------|------|----------|
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## SEARCH NOTES (INCLUDING SEARCH STRATEGY)

|  | DATE    | EXMR |
|--|---------|------|
| monitors, vacuum,<br>electron source, gels<br>sawd | 4/11/03 | 517  |
| clutches, envelopes,<br>multiple, caps             | 1/10/04 | 20   |
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